## Notice of References Cited Application/Control No. 10/765,087 Examiner Wayne Cai Applicant(s)/Patent Under Reexamination CHOI ET AL. Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-6,839,576 B2	01-2005	Aagaard et al.	455/575.1
*	В	US-2003/0203747 A1	10-2003	Nagamine, Yasuo	455/575.3
*	С	US-2004/0204122 A1	10-2004	Opela et al.	455/565
	D	US-			
	Е	US-			
	F	US-			
	G	US-			
	Н	US-			
	1	US-			
	J	US-			
	К	US-			
	L	US-			
	м	US-			

## **FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Q					
	R					
	S					
	T					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)						
	υ							
	٧							
	W							
	х							

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.